



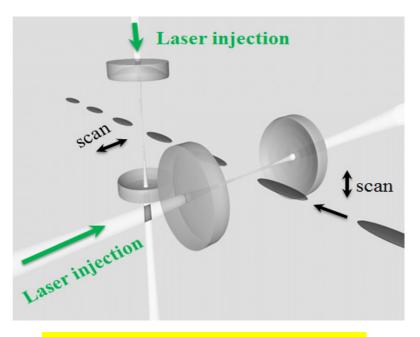
PULSED GREEN LASER WIRE SYSTEM FOR EFFECTIVE INVERSE COMPTON SCATTERING

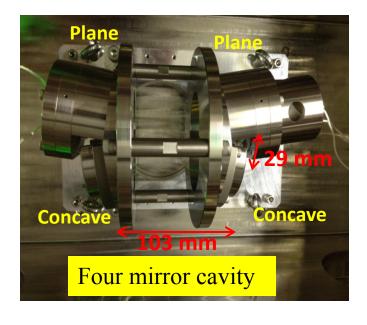
JUNJI URAKAWA (INSTEAD OF ARPIT RAWANKAR)

SOKENDAI, HIGH ENERGY ACCELERATOR RESEARCH ORGANIZATION [KEK], TSUKUBA, JAPAN

IBIC-2014

Purpose and Motivation





CW Green Laser Two Mirror Laser Wire system



Pulsed Green Laser Four Mirror Laser Wire System

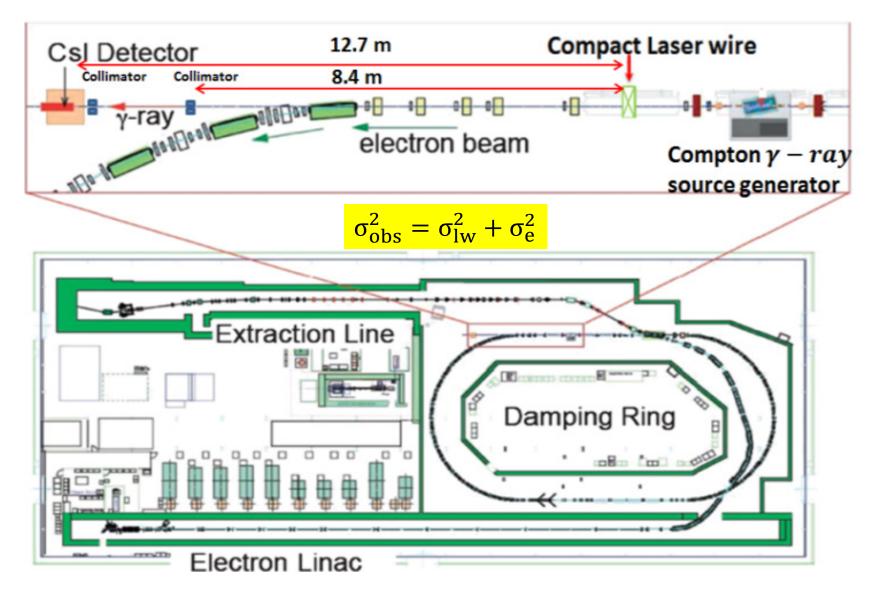
ATF DR has vertical electron beam size of 5 μm .

Small waist size of laser is required to measure small electron beam in vertical direction.

Replace CW two mirror laser wire system with pulse four mirror laser wire system for fast scanning of electron beam and stability of laser system

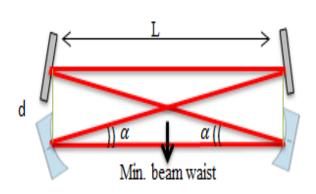
IBIC-2014

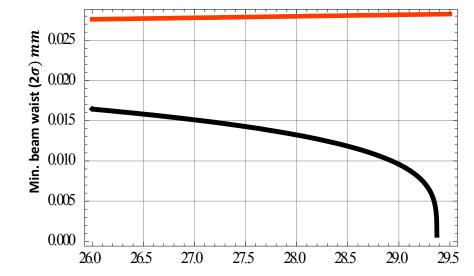
ATF Damping Ring



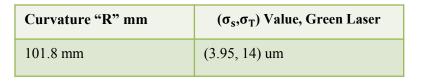
IBIC-2014

Four Mirror Cavity Design Values (R, d)

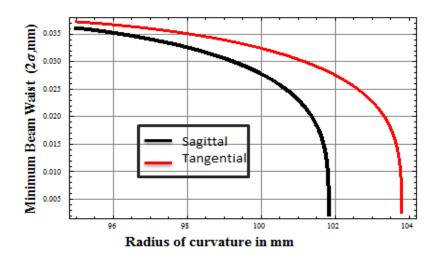




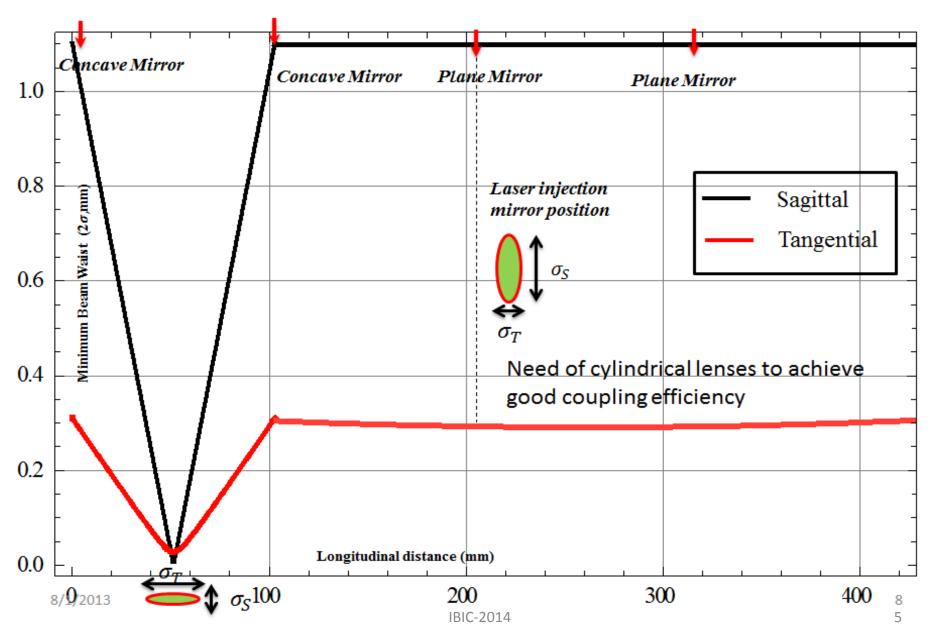
Adjacent Plane mirror-concave mirror distance in mm



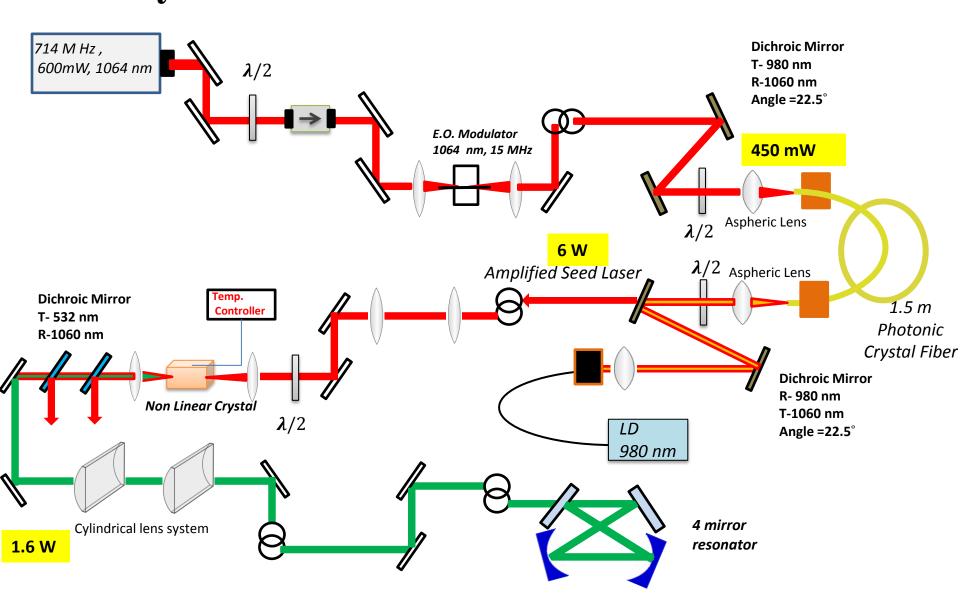
"d" mm	(σ_s, σ_T) value, Green Laser	
29	(4.8, 14.1) um	
29.1	(4.4,14.15) um	
29.2	(3.95, 14.2) um	



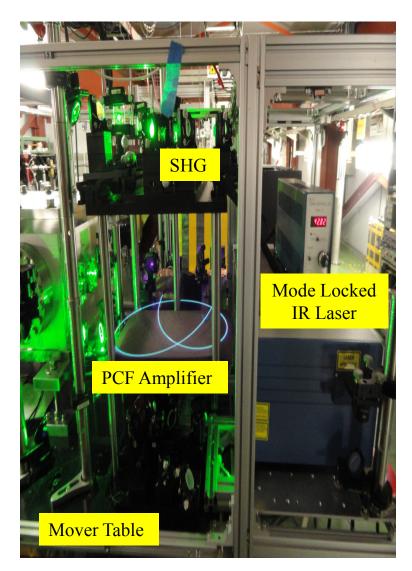
Beam Evolution Inside Four Mirror Resonator

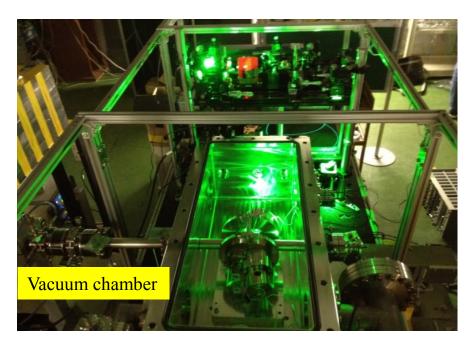


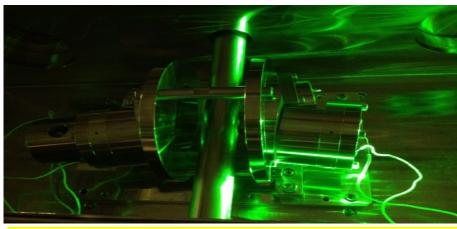
Total System for Pulsed Green Laser Generation



Total System in ATF-DR



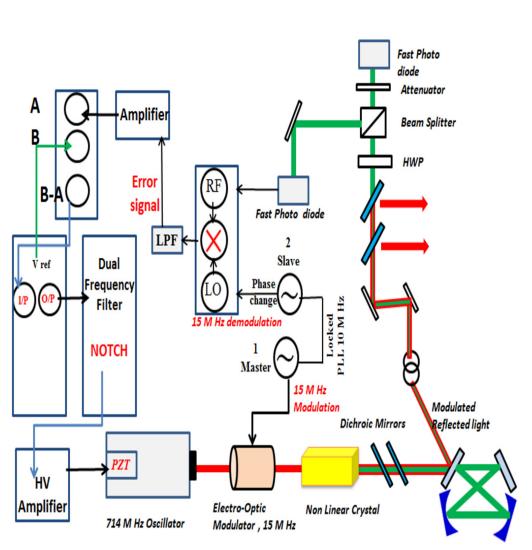


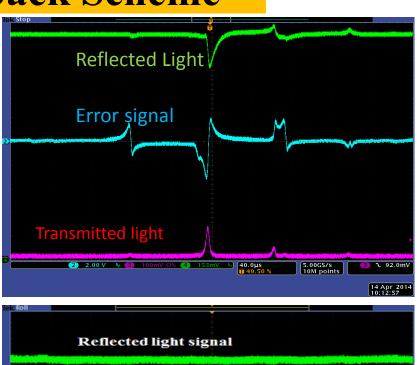


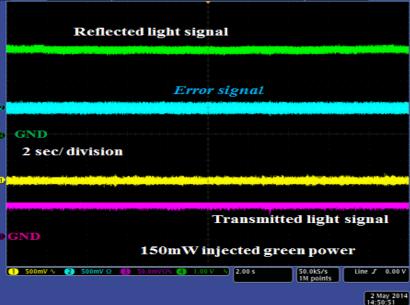
IBIC-2014

Electron beam pipe inside four mirror cavity 90° collision

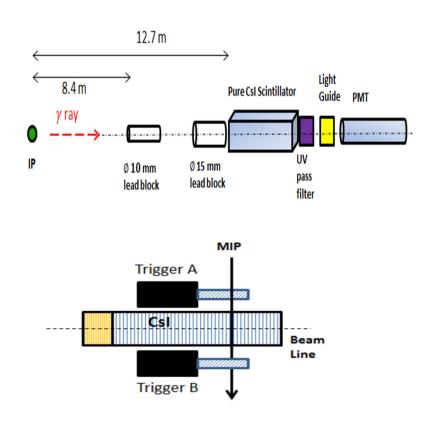
Pound-Drever-Hall Feedback Scheme





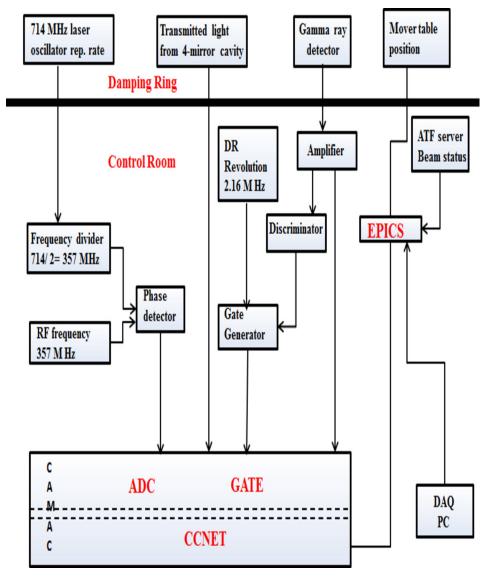


Detector & Data Acquisition System

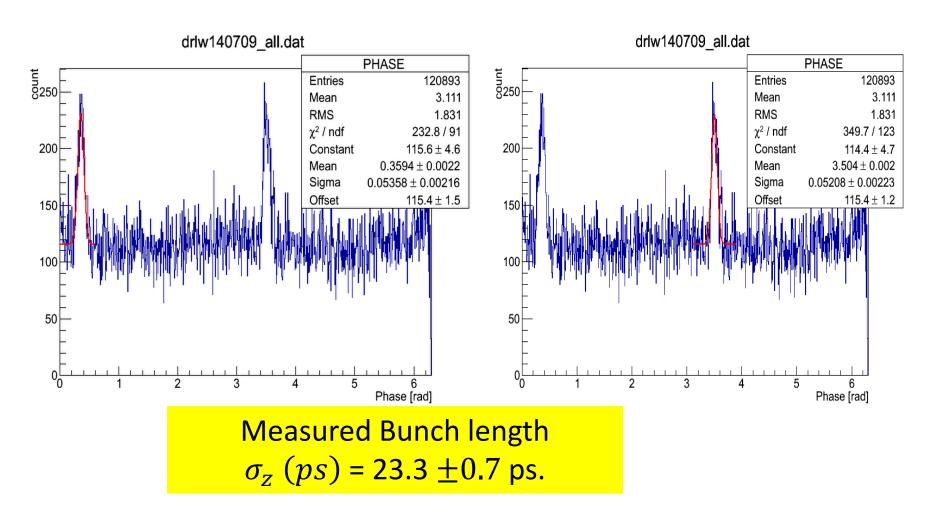


Dimensions of CsI crystal = $70 \times 70 \times 300 \ mm^3$

When muon passes through 70 mm in CsI crystal, Energy deposition will be 39.2 MeV.

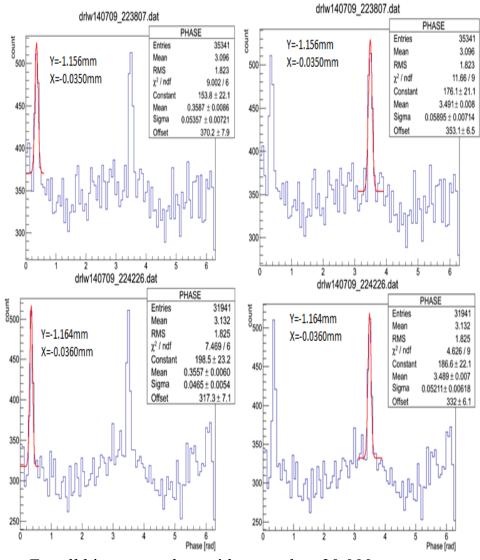


Bunch Length Measurement

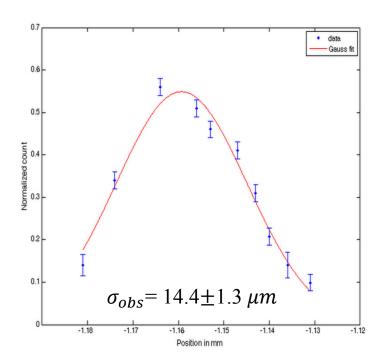


ATF Clock of 357 MHz is used in Experiment. Relative phase difference of 2π corresponds to 2.8 ns

Vertical Beam Size and Emittance Measurement



For all histogram plots with more than 30,000 events, average background level =332 counts



Normalized peak count is ratio of Peak S/N ratio and normalized background level

Normalized peak S/N ratio = 0.56 ± 0.02

$$\sigma_{\text{obs}}^2 = \sigma_{\text{lw}}^2 + \sigma_{\text{e}}^2$$

$$\sigma_{\text{e}}^2 = \sigma_{\text{obs}}^2 - \sigma_{\text{lw}}^2$$

$$\sigma_{lw} = 7 \pm 2 \, \mu m$$

$$\sigma_{ey}$$
= 12.6 \pm 1.6 μm .

Vertical emittance

$$\sigma_{ey} = \sqrt{\beta_y \epsilon_y}$$

$$\beta_{v}$$
 = 6.58 m

$$\epsilon_{v}$$
= 24.1 ±6.1 pm-rad

Conclusion

4 mirror cavity

L	103 mm	
d	29.2 mm	
Minimum Laser Beam size ($\sigma_{ m S,} \ \sigma_{ m T}$)	7 ± 2 μ m , 13.4 ± 3 μ m	
Storage Power	17.5 W	
Enhancement Factor	960	
Finesse	2315 ±220	

Pulsed green generation.

Vertical minimum Beam size of laser 7 $\pm 2 \mu m$.

Four mirror cavity is less sensitive towards misalignment as compare to two mirror cavity.

Electron beam profile measurement

Parameter	Measured Value
Normalized count rate	6.2 <u>±</u> 1.1 kHz/mA
Back ground level	11 <u>±</u> 1 kHz/mA
Bunch length	23.3±0.7 ps
Electron beam size (σ_{ey})	12.6±1.8 μm
Vertical emittance	24.1 <u>+</u> 6.8 pm-rad

Bunch length measurement with accuracy of less than 1 pm.

Measurement of electron beam profile with free phase scan technique.

Thank You Very Much